



Attorney's Docket No. 015290-506

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JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of

Ting CHIEN et al.

Application No.: 09/820,692

Filed: March 30, 2001

For: PLASMA ETCHING OF
DIELECTRIC LAYER WITH
SELECTIVITY TO STOP LAYER

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)
) Group Art Unit: 1765

)
) Examiner: KIN CHAN CHEN

)
) Confirmation No.: 5245

)
) Appeal No.:
)

APPEAL BRIEF – TRANSMITTAL LETTER

Mail Stop APPEAL BRIEF - PATENTS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed is an Appeal Brief for the above-identified patent application.

- ☒ A Petition for Extension of Time is also enclosed.
- ☒ A check covering the ☐ \$250.00 (2402) ☒ \$500.00 (1402) Government fee is filed herewith.
- ☐ Charge ☐ \$250.00 (2402) ☐ \$500.00 (1402) to Credit Card. Form PTO-2038 is attached.

The Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§1.16, 1.17, and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

Burns, Doane, Swecker & Mathis, L.L.P.

Date July 14, 2005

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